



85527PCW  
Customer No. 01333

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Robert P. Fabinski, et al

VARYING FEATURE SIZE IN  
RESIST ACROSS THE CHIP  
WITHOUT THE ARTIFACT OF  
"GRID-SNAPPING" FROM THE  
MASK WRITING TOOL

Serial No. 10/706,200

Filed 12 November 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313-1450

Sir:

Group Art Unit: 2881

Examiner: Zia R. Hashmi

I hereby certify that this correspondence is being  
deposited today with the United States Postal  
Service as first class mail in an envelope addressed  
to Commissioner For Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450.

*Lois A. Massar*  
Lois A. Massar

*Aug. 13, 2004*  
Date

**Amendment**

In response to the office action mailed May 21, 2004, please  
amend the above-identified application, without prejudice, as set forth below:

**Amendments to the Claims** are reflected in the listing of claims, which begins  
on page 2 of this paper.

**Discussion Regarding the Drawings** begin on page 4 of this paper

**Remarks/Arguments** begin on page 5 of this paper.